PTO/SB/08 (08-03)
Approved for use through 07/31/2006. OMB 0651-0031
U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE

				e required to respond to a collection of information unless it contains a valid OMB control number.  Complete if Known			
Substitute for form 1449/PTO				Application Number	10/756,627		
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)				Filing Date	1/13/2004		
				First Named Inventor	Heideman, Rene 2874 n/a		
				Art Unit			
				Examiner Name			
Sheet	1	of	1	Attorney Docket Number	145-001US	/	

		NON PATENT LITERATURE DOCUMENTS	
Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T²
51		ZHANG, ET AL., Res. Stress Charact. of Thick PECVD TEOS Film for Power MEMS Apps, Proc. Solid-State Sensor and Actuator Workshop, Hilton Head, SC, June 4-8, 2000	
SI		SMITH, ET AL., Monolithic integration of waveguide structures with surface-micromachined polysilicon actuators, Smart Structures and Materials, Feb. 1996,	
SP		MCCANN, ET AL., Conformal deposition of LPCVD TEOS, Micro-machining and Micro-fabrication Process Technology, SPIE, Oct. 2001.	
X			

Examiner	Com Back	Date	80105
Signature	The -	Considered	07.700

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

considered. Include copy or this form with next communication to applicant.

1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is effacted.

This collection of information is required by 37 CFR 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Petent and Trademark Office, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO:

Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.